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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 3652  
Examiner: James J. Keenan

In Re PATENT APPLICATION OF:

Applicants : Muh-Wang LIANG et al. )  
Serial No. : 09/619,388 )  
Filed : July 19, 2000 )  
For : APPARATUS FOR )  
LOADING/UNLOADING WAFERS )  
TO AND FROM SEMICONDUCTOR )  
FABRICATION EQUIPMENT )  
Attorney Ref. : LIE 105 )

**AMENDMENT**

August 23, 2004

**Mail Stop Non-Fee Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Sir:

Dear Sir:

This is in response to the Office Action dated June 23, 2004 in connection with the above-identified patent application. Please amend the subject patent application as follows: